

RECEIVED
CENTRAL FAX CENTER

JUL 05 2006

FACSIMILE COVER SHEET

SALIWANCHIK, LLOYD & SALIWANCHIK

A Professional Association

P.O. Box 142950

Gainesville, FL 32614-2950

Telephone (352) 375-8100

Facsimile (352) 372-5800

The information contained in this facsimile message is intended only for the personal and confidential use of the designated recipients named below. This message may be an attorney-client communication, and as such is privileged and confidential. If the reader of this message is not the intended recipient or an agent responsible for delivering it to the intended recipient, you are hereby notified that you have received this document in error, and that any review, dissemination, distribution, or copying of this message is strictly prohibited. If you have received this communication in error, please notify us immediately by telephone and return the original message by mail. Thank you.

TO: Examiner Steven J. Fulk ART UNIT 2891

FAX NO.: (571)-273-8300

FROM: Sarah J. knight

DATE: July 5, 2006

NO. OF PAGES (INCLUDING COVER SHEET): 5

SUBJECT/MESSAGE:

Re: U.S. Patent Application Serial No. 10/743,608; filed December 22, 2003
Methods for Forming Capacitors and Contact Holes of Semiconductor Devices
Simultaneously
(Nan)
Attorney Docket No. SUN-DA-116T

Attachment: Amendment Under 37 CFR §1.111 (4 page)

**OFFICIAL COMMUNICATION PLEASE DELIVER
IMMEDIATELY**

If you do not receive all pages or if any transmission is not legible, call the sender at (352)375-8100.

CENTRAL FAX CENTER

JUL 05 2006

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on the date shown below:

July 5, 2006

Sarah J. Knight

Sarah J. Knight, Patent Agent

AMENDMENT UNDER 37 C.F.R. §1.111

Examining Group 2891

Patent Application

Docket No. SUN-DA-116T

Serial No. 10/743,608

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner : Steven J. Fulk
Art Unit : 2891
Applicant : Sang Woo Nam
Serial No. : 10/743,608
Filed : December 22, 2003
Confirm. No. : 7552
For : Methods for Forming Capacitors and Contact Holes of
Semiconductor Devices Simultaneously

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action dated April 5, 2006, please amend the above-identified application as follows: